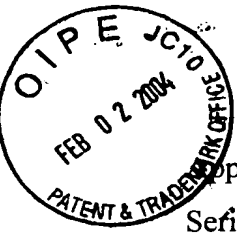


2825
[11403/13]



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED
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10000 MAIL ROOM

Applicant(s) : Markus LUTZ
Serial No. : 10/092,890
Filing Date : March 6, 2002
For : SI WAFER-CAP WAFER BONDING METHOD USING
LOCAL LASER ENERGY, DEVICE PRODUCED BY THE
METHOD, AND SYSTEM USED IN THE METHOD

Group Art Unit : 2825

Examiner : Yevsikov, Victor

Confirmation No. : 1147

Attorney Docket No. : 11403/13

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the
United States Postal Service with sufficient postage as first class mail
in an envelope addressed to:
Mail Stop _____
Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450
on _____

Date: 1/30/2004

Signature: 

AARON C. DEDITCH
(33,865)

RESPONSE TO RESTRICTION/ELECTION REQUIREMENT

SIR:

In the Office Action mailed on January 14, 2004 (the one-month response date for which
is February 16, 2004), the Examiner required restriction/election as follows:

Restriction was required as between "Group I" of claims 19-39 and "Group II" of claims
1-18.

Accordingly, Applicant elects without traverse Group II (claims 1 to 18).

Applicants respectfully request an early and favorable action on the merits.

While no fee is believed to be due, the Commissioner is authorized, as appropriate
and/or necessary, to charge any additional fees (including any Rule 136(a) extension fees) or
credit any overpayment to Deposit Account No. 11-0600. A duplicate copy of this paper is
enclosed for this purpose.

Respectfully submitted,

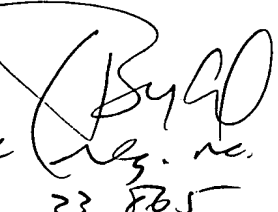
Dated: 1/30/2004

By: 

Richard L. Mayer
(Reg. No. 22,490)

KENYON & KENYON
One Broadway
New York, New York 10004
(212) 425-7200

CUSTOMER NO. 26646


By: Aaron C. Deditch
(Reg. No. 33,865)